

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hisashi OHTANI et al.

Serial No. 09/550,598

Filed: April 17, 2000

For: SEMICONDUCTOR DEVICE AND
PROCESS FOR PRODUCING THE
SAME

Group Art Unit: 2814

Examiner: P. Cao



CERTIFICATE OF MAILING

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4-11-05

Adrian M. Stampas

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.